

12/28/2010

4319.70023

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yoichiro Ohta )  
)  
Serial No.: 10/796,344 )  
)  
Conf. No.: 1978 )  
)  
Filed: 3/9/2004 )  
)  
For: VACUUM PROCESSING )  
APPARATUS )  
)  
Art Unit: 1716 )  
)  
Examiner: Lund, Jeffrie Robert )

**AMENDMENT AFTER NOTICE OF ALLOWANCE UNDER 37 C.F.R. 1.312**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Prior to issuance of the above-named allowed Application, please enter the following amendments: